

**CERTIFICATE OF ELECTRONIC  
TRANSMISSION**

I hereby certify that this correspondence for Application No. 10/524,525 is being electronically transmitted to Technology Center 1765, via EFS-WEB, on January 28, 2008.

/David H. Brinkman/ 1/28/08  
David H. Brinkman, Reg. No. 40,532 Date

**PATENT**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicant: Martin Hausner  
Serial No.: 10/524,525  
Filed: August 18, 2005  
Confirmation No.: 1134  
Group Art Unit: 1792  
Examiner: Ahmed, Shamim  
Title: **METHOD FOR SELECTIVELY REMOVING MATERIAL FROM  
THE SURFACE OF A SUBSTRATE, MASKING MATERIAL FOR  
A WAFER, AND WAFER WITH MASKING MATERIAL**  
Atty. Docket: BEET-09

Cincinnati, Ohio 45202

January 28, 2008

Mail Stop RCE  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

**SUPPLEMENTAL AFTER FINAL AMENDMENT**

In response to the Final Office Action mailed on September 26, 2007, and supplementing the After Final Response filed on December 26, 2007, please amend the above-identified application as follows:

**Amendments to the Claims** are reflected in the listing of claims which begins on page 2 of this paper.

**Remarks/Arguments** begin on page 11 of this paper.